INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 17, 2026

IGI Report Number	LG818666901
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	6.77 X 6.36 X 4.16 MM

GRADING RESULTS

Carat Weight	1.56 CARAT
Color Grade	E
Clarity Grade	VVS 2

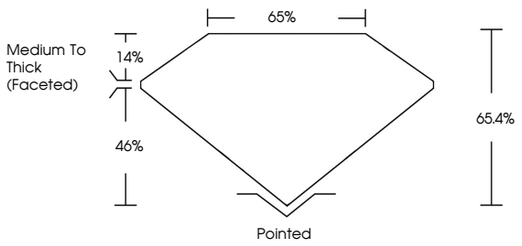
ADDITIONAL GRADING INFORMATION

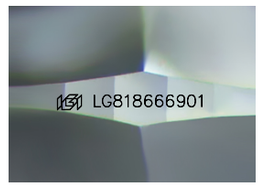
Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG818666901

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG818666901
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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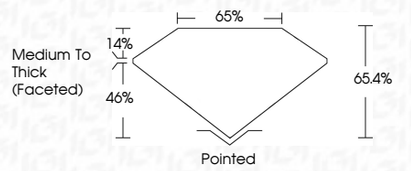
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IGI

August 17, 2026
IGI Report No LG818666901
CUSHION MODIFIED BRILLIANT
6.77 X 6.36 X 4.16 MM
Carat Weight 1.56 CARAT
Color Grade E
Clarity Grade VVS 2
Depth 65.4%
Table 65%
Girdle Medium To Thick (Faceted)
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG818666901
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Type IIa